

### Amendments to the Claims

This listing of claims replaces all prior versions and listings of claims in the application

### Listing of Claims

1. (Currently amended) An apparatus for forming a film comprising:  
a load chamber;  
a conveyance chamber connected to the load chamber;  
a film formation chamber connected to the conveyance chamber; and  
an installation chamber connected to the film formation chamber, and comprising means adapted to move a first evaporation source, means adapted to move a second evaporation source, and means adapted to move a third evaporation source,

wherein each of the means adapted to move the first, second, and third evaporation sources is configured to move in an X direction, a Y direction, and a Z direction in the film formation chamber, and

~~wherein the installation chamber comprises a mechanism for setting an evaporation material in each of the first, second, and third evaporation sources in the installation chamber.~~

wherein an evaporation is performed while at least one of the means adapted to move the first, second, and third evaporation sources moves in the film formation chamber.

2. (Previously Presented) The apparatus for forming the film according to claim 1,  
wherein the installation chamber is connected to evacuating and exhausting means that evacuates the installation chamber.

3. (Previously Presented) The apparatus for forming the film according to claim 1,  
wherein the film formation chamber is connected to an evacuation and exhaust treatment chamber that evacuates the film forming chamber and has means for introducing at least one of a material gas and a cleaning gas.

4. (Canceled)

5. (Previously Presented) The apparatus for forming the film according to claim 1, wherein the film formation chamber has a shutter that sections the film formation chamber and shields evaporation to the substrate.

6. (Previously Presented) The apparatus for forming the film according to claim 1, wherein a sealing chamber is connected to the conveyance chamber, and wherein the sealing chamber is connected to evacuating and exhausting means, which evacuates the sealing chamber, and has a mechanism for applying a seal material with an ink jet method in the sealing chamber.

7. (Currently amended) An apparatus for forming a film comprising:  
a load chamber;  
a conveyance chamber connected to the load chamber;  
a film formation chamber connected to the conveyance chamber; and  
an installation chamber connected to the film formation chamber, and comprising means adapted to move a first evaporation source, means adapted to move a second evaporation source, and means adapted to move a third evaporation source,

wherein the film formation chamber comprises an aligning means that aligns a mask and a substrate,

wherein each of the means adapted to move the first, second, and third evaporation sources is configured to move in an X direction, a Y direction, and a Z direction in the film formation chamber, and

~~wherein the installation chamber comprises a mechanism for setting an evaporation material in each of the first, second, and third evaporation sources in the installation chamber.~~

wherein an evaporation is performed while at least one of the means adapted to move the first, second, and third evaporation sources moves in the film formation chamber.

8. (Previously Presented) The apparatus for forming the film according to claim 7, wherein the installation chamber is connected to evacuating and exhausting means that evacuates the installation chamber.

9. (Previously Presented) The apparatus for forming the film according to claim 7, wherein the film formation chamber is connected to an evacuation and exhaust treatment chamber that evacuates the film forming chamber and has means for introducing at least one of a material gas and a cleaning gas.

10. (Canceled)

11. (Previously Presented) The apparatus for forming the film according to claim 7, wherein the film formation chamber has a shutter that sections the film formation chamber and shields evaporation to the substrate.

12. (Previously Presented) The apparatus for forming the film according to claim 7, wherein a sealing chamber is connected to the conveyance chamber, and wherein the sealing chamber is connected to evacuating and exhausting means, which evacuates the sealing chamber, and has a mechanism for applying a seal material with an ink jet method in the sealing chamber.

13. (Currently amended) An apparatus for forming a film comprising:  
a load chamber;  
a conveyance chamber connected to the load chamber;  
a film formation chamber connected to the conveyance chamber; and  
an installation chamber connected to the film formation chamber, and comprising means adapted to move a first evaporation source, means adapted to move a second evaporation source, and means adapted to move a third evaporation source,  
wherein the first, second, and third evaporation sources have containers with elliptical openings,

wherein each of the means adapted to move the first, second, and third evaporation sources is configured to move in an X direction, a Y direction, and a Z direction in the film formation chamber, and

~~wherein the installation chamber comprises a mechanism for setting an evaporation material in each of the first, second, and third evaporation sources in the installation chamber.~~

wherein an evaporation is performed while at least one of the means adapted to move the first, second, and third evaporation sources moves in the film formation chamber.

14. (Previously Presented) The apparatus for forming the film according to claim 13, wherein the installation chamber is connected to evacuating and exhausting means that evacuates the installation chamber.

15. (Previously Presented) The apparatus for forming the film according to claim 13, wherein the film formation chamber is connected to an evacuation and exhaust treatment chamber that evacuates the film forming chamber and has means for introducing at least one of a material gas and a cleaning gas.

16. (Canceled)

17. (Previously Presented) The apparatus for forming the film according to claim 13, wherein the film formation chamber has a shutter that sections the film formation chamber and shields evaporation to the substrate.

18. (Previously Presented) The apparatus for forming the film according to claim 13, wherein a sealing chamber is connected to the conveyance chamber, and wherein the sealing chamber is connected to evacuating and exhausting means, which evacuates the sealing chamber, and has a mechanism for applying a seal material with an ink jet method in the sealing chamber.

19. (Currently amended) An apparatus for forming a film comprising:

a load chamber;  
a conveyance chamber connected to the load chamber;  
a film formation chamber connected to the conveyance chamber; and  
an installation chamber connected to the film formation chamber, and comprising means adapted to move a first evaporation source, means adapted to move a second evaporation source, and means adapted to move a third evaporation source,

wherein the first, second, and third evaporation sources have containers with inclined openings,

wherein each of the means adapted to move the first, second, and third evaporation sources is configured to move in an X direction, a Y direction, and a Z direction in the film formation chamber, and

~~wherein the installation chamber comprises a mechanism for setting an evaporation material in each of the first, second, and third evaporation sources in the installation chamber.~~

wherein an evaporation is performed while at least one of the means adapted to move the first, second, and third evaporation sources moves in the film formation chamber.

20. (Previously Presented) The apparatus for forming the film according to claim 19, wherein the installation chamber is connected to evacuating and exhausting means that evacuates the installation chamber.

21. (Previously Presented) The apparatus for forming the film according to claim 19, wherein the film formation chamber is connected to an evacuation and exhaust treatment chamber that evacuates the film forming chamber and has means for introducing at least one of a material gas and a cleaning gas.

22. (Canceled)

23. (Previously Presented) The apparatus for forming the film according to claim 19, wherein the film formation chamber has a shutter that sections the film formation chamber and shields evaporation to the substrate.

24. (Previously Presented) The apparatus for forming the film according to claim 19, wherein a sealing chamber is connected to the conveyance chamber, and wherein the sealing chamber is connected to evacuating and exhausting means, which evacuates the sealing chamber, and has a mechanism for applying a seal material with an ink jet method in the sealing chamber.

25-28. (Canceled)

29. (Withdrawn) The apparatus for forming the film according to claim 1, wherein the installation chamber further comprises a first installation chamber, a second installation chamber, and a third installation chamber, and wherein the means adapted to move the first evaporation source is provided in the first installation chamber, the means adapted to move the second evaporation source is provided in the second installation chamber, and the means adapted to move the third evaporation source is provided in the third installation chamber.

30. (Withdrawn) The apparatus for forming the film according to claim 7, wherein the installation chamber further comprises a first installation chamber, a second installation chamber, and a third installation chamber, and wherein the means adapted to move the first evaporation source is provided in the first installation chamber, the means adapted to move the second evaporation source is provided in the second installation chamber, and the means adapted to move the third evaporation source is provided in the third installation chamber.

31. (Withdrawn) The apparatus for forming the film according to claim 13, wherein the installation chamber further comprises a first installation chamber, a second installation chamber, and a third installation chamber, and wherein the means adapted to move the first evaporation source is provided in the first installation chamber, the means adapted to move the second evaporation source is provided in the second installation chamber, and the means adapted to move the third evaporation source is provided in the third installation chamber.

32. (Withdrawn) The apparatus for forming the film according to claim 19, wherein the installation chamber further comprises a first installation chamber, a second installation chamber, and a third installation chamber, and wherein the means adapted to move the first evaporation source is provided in the first installation chamber, the means adapted to move the second evaporation source is provided in the second installation chamber, and the means adapted to move the third evaporation source is provided in the third installation chamber.

33. (Previously Presented ) The apparatus for forming the film according to claim 1, wherein the installation chamber comprises a single installation chamber, and wherein the means adapted to move the first evaporation source, the means adapted to move the second evaporation source, and the means adapted to move the third evaporation source are provided in the single installation chamber.

34. (Previously Presented) The apparatus for forming the film according to claim 7, wherein the installation chamber comprises a single installation chamber, and wherein the means adapted to move the first evaporation source, the means adapted to move the second evaporation source, and the means adapted to move the third evaporation source are provided in the single installation chamber.

35. (Previously Presented) The apparatus for forming the film according to claim 13, wherein the installation chamber comprises a single installation chamber, and wherein the means adapted to move the first evaporation source, the means adapted to move the second evaporation source, and the means adapted to move the third evaporation source are provided in the single installation chamber.

36. (Previously Presented) The apparatus for forming the film according to claim 19, wherein the installation chamber comprises a single installation chamber, and wherein the means adapted to move the first evaporation source, the means adapted to move the second evaporation source, and the means adapted to move the third evaporation source are provided in the single installation chamber.